

Freeform Search

Database:	US Pre-Grant Publication Full-Text Database
	US Patents Full-Text Database
	US OCR Full-Text Database
	EPO Abstracts Database
	JPO Abstracts Database
	Derwent World Patents Index
	IBM Technical Disclosure Bulletins

Term:	<input type="text" value="L1 and nitride"/>
--------------	---

Display:	<input type="text" value="10"/>	Documents in Display Format:	<input type="text" value="-"/>	Starting with Number	<input type="text" value="1"/>
-----------------	---------------------------------	-------------------------------------	--------------------------------	-----------------------------	--------------------------------

Generate:	<input type="radio"/> Hit List	<input checked="" type="radio"/> Hit Count	<input type="radio"/> Side by Side	<input type="radio"/> Image
------------------	--------------------------------	--	------------------------------------	-----------------------------

Search History

DATE: Sunday, March 20, 2005 [Printable Copy](#) [Create Case](#)

<u>Set</u> <u>Name</u> side by side	<u>Query</u>	<u>Hit</u> <u>Count</u>	<u>Set</u> <u>Name</u> result set
	<i>DB=PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD; PLUR=YES; OP=OR</i>		
<u>L2</u>	L1 and nitride	95	<u>L2</u>
<u>L1</u>	capacitor and ((ALD or (atomic adj layer adj deposition)) with (aluminum adj oxide))	120	<u>L1</u>

END OF SEARCH HISTORY